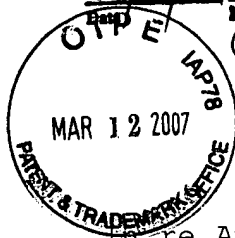


CERTIFICATE OF MAILING
I hereby certify that this paper and every
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on MARCH 8, 2007 (Date of Deposit)

PATENT

Atty. Docket No.: 006915 USA P02/IMPLANT/P3I/AG



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Kenneth Collins, et al. :
:
Entitled: PLASMA IMMERSION ION :
IMPLANTATION APPARATUS USING A : Group Art Unit: 2813
PLASMA SOURCE HAVING LOW :
DISSOCIATION AND LOW MINIMUM :
PLASMA VOLTAGE :
Examiner: Jack S. Chen
Serial No.: 10/646,533 :
Filing Date: August 22, 2003 :

**AMENDMENT UNDER 37 CFR. 1.111
(RESPONSE TO DOUBLE PATENTING REJECTION)**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 9, 2007,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims
which begins on page 2 of this paper.

Remarks/Arguments begin on page 18 of this paper.